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4.9.03

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Docket No. 740819-408

C. Moore

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hiroaki NAKAOKA et al.

Serial No. 09/640,519

Filed: August 17, 2000

For: METHOD OF FABRICATING
SEMICONDUCTOR DEVICE

)
) Group Art Unit: 2818
) Examiner: David VU
)
) Date: April 3, 2003

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TO: [unclear]
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AMENDMENT AFTER FINAL

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed December 4, 2002, please consider the following amendments and remarks in connection with the above-identified application.